FEB 14 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	10/050,334
Filing Date	
Inventor	
Assignee	Micron Technology, Inc.
Group Art Unit	2813
Examiner	
Attorney's Docket No	Ml22-1913
Title: Capacitor Fabrication Methods and Enhanced Surface	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 14 Feb 2006

By:

Sheet 1 of 1

Form PTO-	-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY, DOCKET NO. MI22-1913			SERIAL NO. 10/050,334			
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